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AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROSECUTION - GROUP ART UNIT 1762

03500.014241

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
NOBUHIRO ITO) Examiner: B. Talbot
Application No.: 09/505,627) Group Art Unit: 1762
Filed: February 16, 2000)
For: MANUFACTURING METHOD OF)
ELECTRON BEAM APPARATUS :
AND SPACER, AND ELECTRON)
BEAM APPARATUS : August 19, 2004

*(SAC)
DR not seen
9/10/04*

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Mail Stop AF

AMENDMENT AFTER FINAL REJECTION

Sir:

A. Introductory Comments

In response to the final Office Action dated May 20, 2004, please amend the application as follows and consider the following remarks.